Microelectronic Grade Silicone Materials for CSP

Mike Gaul, Ann Norris Stanton Dent,

Dow Corning Corporation



Outline

- The nature of silicones
- Silicone polymerization
- Root cause of silicone outgassing
- Development of materials for use in the uBGA package
- Resolution of Lead bond issues
- X-ray Photoelectron Spectroscopy images
- Conclusions



Nature of Silicones

egree of Alkyl Substitution

 SiO_2

Silica

Glasses

 $R_1SiO_{3/2}$

Silsesquioxanes Silicone resins 7

O-Si-O CH₃

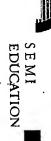
R₂SiO

Silicone

polymers

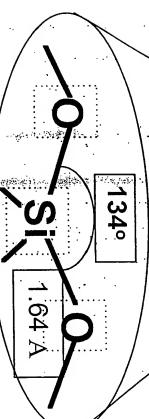
Hard & Brittle

Soft & Flexible



Properties of Silicone Fluids

 Me_3S $SiMe_3$



- Wide OSiO angle => Fr
- Free rotation, low Tg, Tm, etc
- Strong Si-O Bond =>
- **High Thermostability**
- PDMS backbones are covered by CH₃'s, hydrophobicity



Silicone Properties*

- Liquid at high molecular weight
- Low apparent activation energy for viscous flow
- Low surface energy
- High gas permeability
- High dielectric strength

- Thermal stability
- Oxidative resistance
- Low boiling points
- Excellent flammability properties
- Low surface shear viscosity
- Relative to hydrocarbon materials



Equilibration Polymerization of Silicones

- Acid or base catalysis
- Time, temperature and solvent effects
- Molecular weight control
- End block
- trimethylsilyl
- dimethylhydroxyl
- dimethylvinyl
- others



Equilibration Polymerization of Silicones

Polymerization:

$$x(Me_2SiO)_4 + Me_3SiOSiMe_3 \xrightarrow{Cat} (Me_2SiO)_y + Me_3SiO(Me_2SiO)_z$$
 SiMe_3

- Equilibrium mixture of cyclics and linears
- High Mw linear polymer
- Typically 11-18 wt. % cyclics for PDMS
- Low molecular weight species are very volatile and low viscosity



Low Mw Silicones

	Viscosity	Boiling	
	@ 25 C	Point	Mw
Compound	cŚ	C	
Water	1.0	100	18
MM	0.7	101	162
D ₃	·	135	222
MDM	1.0	153	237
_ D4	2.3	175	297
MD ₂ M	1.5	. 196	311
D ₅	3.9	211	371
MD ₃ M	2.1	230	. 385
D_6	6.6	245	445
MD ₄ M	2.6	· 260	459
D7 .	9.5	276	519
MD ₅ M	3.2	287	. 533
D ₈	13.2	303	593
MD ₆ M	. 3.9	310	. 607
D ₉	18.0	326	667
MD ₇ M	4.5		. 681

$$H_3C$$
 H_3C
 CH_3
 CH_3
 CH_3
 CH_3
 CH_3
 CH_3
 CH_3

M (D)_n M Linear series

Removal of Low Mw Species

- Vacuum strip dependent on:
- time, temperature, vacuum level
- Liquid-liquid solvent extraction
- Non-solvent precipitation
- Super critical fluid extraction
- High pressure liquid chromatography



D13-D20	D4-D12		Compounds		
11860	20600	PPM	Grade	microelectronic	Non-
734	0	PPM	Grade	Microelectronic	

- •Greater than 95% reduction in low Mw species
- •Remaining material is high Mw
- high viscosity & high boiling



Typical Silicone Formulation

- Silicone polymer
- outgassing
- Filler
- Crosslinker
- Adhesion promoter
- Catalyst (Pt)

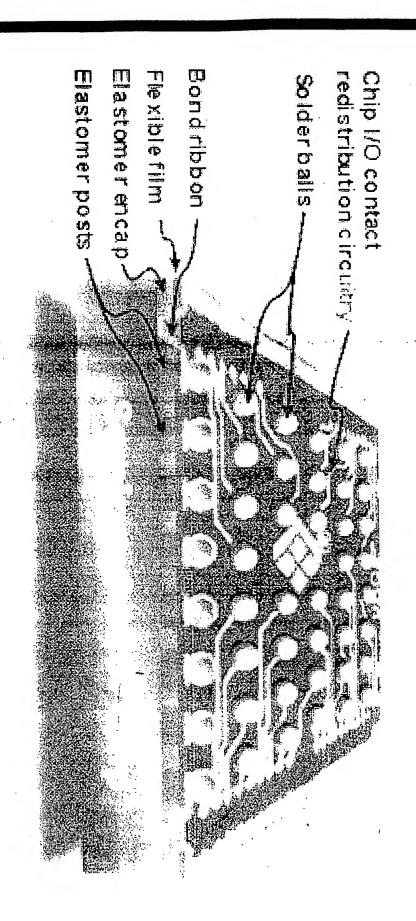


Condensation Cure

- No cure by-products
- •Heat activated
- •Can be 1-part or 2-part



JBGA Package





Material and Process Considerations for CSP Lead Bonding

- Design considerations
- Nubbins or pads
- Proximity to lead bond area
- Material considerations
- Rheology
- Low volatility
- Low creep
- Off set stencil printing
- Gross contamination during printing
- Time between print and cure



Non-microelectronic grade materials led to:

- Migration of silicone onto leads
- Cure silicone nubbins

Self diffusion of low Mw components

- $D \propto 1/Mw^2$
- Surface spreading
- ηαMw
- Outgassing



Use of non-microelectronics grade silicones led to increases in:

- Lead bond ultrasonic frequency
- Cleaning frequency of lead bond tip
- Deformation of the lead
- High failure rate due to heel breaks



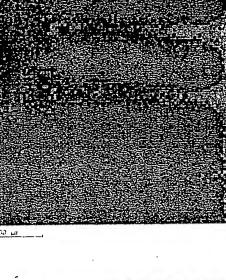
material eliminated all problems: Microelectronics grade silicone

- Increased yield
- Increased productivity
- Increased reliability

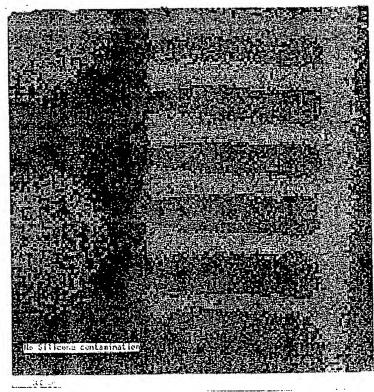


XPS of TAB tape showing leads





Non-Microelectronic Grade Silicone



Microelectronic Grade Silicone

£ :



Summary

- Silicones have unique properties due to their chemical composition
- Equilibration polymerization of silicones
- Low Mw species present root cause
- Can be removed by further processing
- Not all silicone materials are alike
- is commercially available Low outgassing microelectronic grade silicone material set
- outgassing silicone material set. Companies are in production with µBGA using a low



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